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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Response Under 37 CFR 1.116 - Expedited Procedure

:Customer Number: 20277

Takeshi SATOH, et al.

Confirmation Number: 3233

Application No.: 10/750,870

Docket No.: 057454-0994

Group Art Unit: 1754

Filed: January 05, 2004

Examiner: Edward M. Johnson

For: POROUS Si3 N4 AND PRODUCING METHOD THEREOF

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment Under 37 C.F.R. §1.116 in the above-identified application.

No additional fee is required.

Applicant is entitled to small entity status under 37 CFR 1.27

Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	9	20	0	\$50.00 =	\$0.00
Independent Claims	3	3	0	\$200.00 =	\$0.00
		Multiple dependent claims newly presented			\$0.00
		Fee for extension o	Fee for extension of time		
					\$0.00
		Total of Above Calculations		\$0.00	

Please charge my Deposit Account No. <u>500417</u> in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.

The Commissioner is

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

Bris K. Luis

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Facsimile: 202.756.8087 **Date: January 23, 2006** 

Please recognize our Customer No. 20277 as our correspondence address.

**PATENT** 

## Docket No.: 057454-0994

## PATENT AND TRADEMARK OFFICE

Applicant: Takeshi SATOH, et al.

RESPONSE UNDER 37 C.F.R. 1.116

**EXPEDITED PROCEDURE** 

Application No.: 10/750,870

Customer No.: 20277

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Group Art Unit: 1754

Examiner: Edward M. Johnson

Title: POROUS Si3 N4 AND PRODUCING METHOD THEREOF

## AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated October 21, 2005. Please amend the above-identified application as follows.